

<b>Search Notes</b> 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/789,862	LEE, HYOK
	Examiner	Art Unit
	J. Casimer Jacyna	3751

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
251	30-61.2	9/30/2005	CJ
251	331	9/30/2005	CJ